

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Toshiro Kisakibaru et al. **Docket No.** 075834.00456

Serial No.: Herewith

Customer No. 33448

Filed: Herewith

Title: "MANUFACTURING APPARATUS AND MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE"

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

Please amend the application as follows: